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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **JAN EVERT VAN DER WERF et al.**

Application No.: 10/618,264
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Confirmation No.: 3943
Group No.: 2878
Examiner:

For: **LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL APPLICATION DATA SHEET
37 C.F.R. § 1.76(c)

The following information on the Application Data Sheet is changed as indicated:

BIBLIOGRAPHIC DATA

1. Assignee information is being modified.


The assignee(s) of this application is/are:

ASML NETHERLANDS B.V.
De Run 6501, NL-5504 DR Veldhoven, The Netherlands
Extent of interest of assignee in application: ENTIRE RIGHT, TITLE AND INTEREST

Date: June 3, 2004

PILLSBURY WINTHROP LLP
P.O. Box 10500
McLean, VA 22102

Customer No. 00909



Signature of Practitioner
John P. Darling
Registration No. 44482
(703) 905-2045